



PATENT
98095DIV4

*141 Supp
Response
c. Step 2
5/22/03*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815

Examiner: N. Richards

In re application of:

Gonzalez et al.

SEMICONDUCTOR RAISED
SOURCE-DRAIN STRUCTURE

Serial No.: 10/008,653

Filed: November 9, 2001

SUPPLEMENTAL RESPONSE TO OFFICE ACTION

January 13, 2003

Commissioner for Patents
Washington, D.C. 20231

Dear Commissioner:

Further to the December 24, 2002 Amendment and Response to Office Action filed in the captioned patent application, applicants submit the present Supplemental Response, which includes the following:

1. A corrected cover page of the Declaration under 37 C.F.R. §1.131 ("Declaration") that was included in the response dated December 24, 2002, and
2. A marked-up version of the cover page showing the correction made to the Declaration.